

Inventor: Martin Ceredig Roberts et al.

Title: Methods of Forming Capacitors, and Methods of Forming DRAM Circuitry

Assignee: Micron Technology, Inc.

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. " 1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a continuation application of co-pending application Serial No. 09/198,034, filed November 23, 1998. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. § 1.98(d) and MPEP § 609(2).

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: April 2, 2004

By: Jennifer J. Taylor
Jennifer J. Taylor, Ph.D.
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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-2550	SERIAL NO. PRIORITY 09/198,034	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Micron Technology, Inc.		
				FILING DATE PRIORITY November 23, 1998		
U.S. PATENT DOCUMENTS						
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	5,497,017	03-1996	Gonzales		
	AB	5,408,114	04-1995	Kinoshita et al.		
	AC	5,468,670	11-1995	Ryou		
	AD	5,933,742	08-1999	Wu		
	AE	6,031,262	02-2000	Sakao		
	AF	5,939,747	08-1999	Yajima		
	AG	5,872,041	02-1999	Lee et al.		
	AH	5,512,768	04-1996	Lur et al.		
	AI	5,835,337	11-1998	Watanbe et al.		
	AJ	6,259,125	07-2001	Fazan et al.		
	AK	6,256,127	07-2001	Pan		
	AL	6,323,081	09-1998	Marsh		
	AM	5,804,852	11-2001	Yang et al.		
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	AO	5,506,166	04-1996	Sandhu et al.		
	AP	6,002,574	12-1999	Metzler et al.		
	AQ	5,476,805	12-1995	Woo et al.		
FOREIGN PATENT DOCUMENTS						
	Document Number	Date	Country	Class	Subclass	Translation
						Yes No
	AR	DE 004213945 A1	28.04.1992	Germany		
	AS					
	AT					
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)						
	AU					
EXAMINER				DATE CONSIDERED		
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						